



Docket No. TIP477US

TI-33260

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re **PATENT** application of:

Applicant: Patricia B. Smith *et al.*

Application No.: 10/647,985

For: POST-ETCH CLEAN PROCESS FOR POROUS LOW  
DIELECTRIC CONSTANT MATERIALS

Filing Date: August 26, 2003

Examiner: Zeinab El Arini

Art Unit: 1746

**RESPONSE TO OFFICE ACTION DATED MARCH 16, 2006**

Mail Stop Amendment  
Assistant Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Favorable reconsideration of the above-identified application is respectfully requested in view of the following amendments and remarks.